



#11/A  
1/21/03  
Lau  
PATENT

Response Under 37 C.F.R. § 1.114  
Customer No. 22,852  
Attorney Docket No. 3180.0269-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chie IWASA

Application No.: 09/708,490

Filed: November 9, 2000

For: SEMICONDUCTOR TESTING METHOD  
AND SEMICONDUCTOR TESTING  
APPARATUS FOR SEMICONDUCTOR  
DEVICES, AND PROGRAM FOR  
EXECUTING SEMICONDUCTOR TESTING  
METHOD

Group Art Unit: 2863

Examiner: Lau, Tung S.

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Commissioner for Patents  
Washington, DC 20231

Sir:

**AMENDMENT**

This Amendment accompanies a Request for Continued Examination (RCE) thereby fulfilling the requirements for a submission under 37 C.F.R. § 1.114. In reply to the Final Office Action dated September 5, 2002, the period for response having been extended for one month by a Petition for Extension of Time and fee payment filed concurrently herewith, the period for reply extends through January 6, 2003 (January 5<sup>th</sup> being a Sunday), Applicant amends the application as follows:

**IN THE DRAWINGS:**

In a separate Request for Approval of Drawing Changes filed herewith, Applicant proposes to amend Figures 7 and 18 as indicated in red on the attached sheets.

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